



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 09/361,980  
Filing Date: July 28, 1999  
Applicant: Yasuaki Tsuzuki et al.  
Group Art Unit: 1765  
Examiner: L. Umez Eronini  
Title: Method of Etching Metallic Thin Film on Thin Film Resistor  
Attorney Docket: 4041J-000439

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Hon. Commissioner of Patents and Trademarks  
Washington, D.C. 20231

**PETITION TO CORRECT INVENTORSHIP  
UNDER 37 C.F.R. § 1.48(b)**

Dear Sir:

Applicant respectfully requests that the inventorship of the above identified application be corrected pursuant to 37 C.F.R. § 1.48(b). Claims 1-4 have been allowed in this application. Therefore, Ichiro Ito, Satoshi Shiraki, Tomio Yamamoto, Makoto Ohkawa and Atsumi Takahashi should be deleted because their invention is no longer being claimed in the above identified application.


Enclosed is a check for \$130.00 pursuant to 37 C.F.R. § 1.17(i) to cover the fee for this petition.

The Commissioner is hereby authorized to charge any additional fees which may be required to effect this communication or to maintain pendency of this application, or credit any overpayment, to Account No. 08-0750. A duplicate copy of this sheet is enclosed for this purpose.

If the Examiner believes that personal communication will expedite prosecution of this application, the Examiner is invited to telephone the undersigned at (248) 641-1600.

Respectfully submitted,

Dated: April 19, 2002  
HARNESS, DICKEY & PIERCE, P.L.C.  
P.O. Box 828  
Bloomfield Hills, MI 48303  
(248) 641-1600

By:   
Michael J. Schmidt  
Reg. No. 64,007